

RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 09/728,193

Applicant: Etsuo MORITA

Filed: November 30, 2000

Title: METHOD OF MANUFACTURING
CRYSTAL OF III-V COMPOUND
OF THE NITRIDE SYSTEM,
CRYSTAL SUBSTRATE OF III-V
COMPOUND OF THE NITRIDE
SYSTEM, CRYSTAL FILM OF III-V
COMPOUND OF THE NITRIDE
SYSTEM and METHOD OF
MANUFACTURING DEVICE

Examiner: Matthew J. Song

Group Art Unit: 1722

Confirmation No.: 4426

Docket No.: 09792909-4714

August 30, 2006

FILED ELECTRONICALLY VIA EFS-WEB

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Sir:

In response to the final Office Action mailed July 24, 2006, Applicant requests consideration of the following remarks.